

# Future HEP links

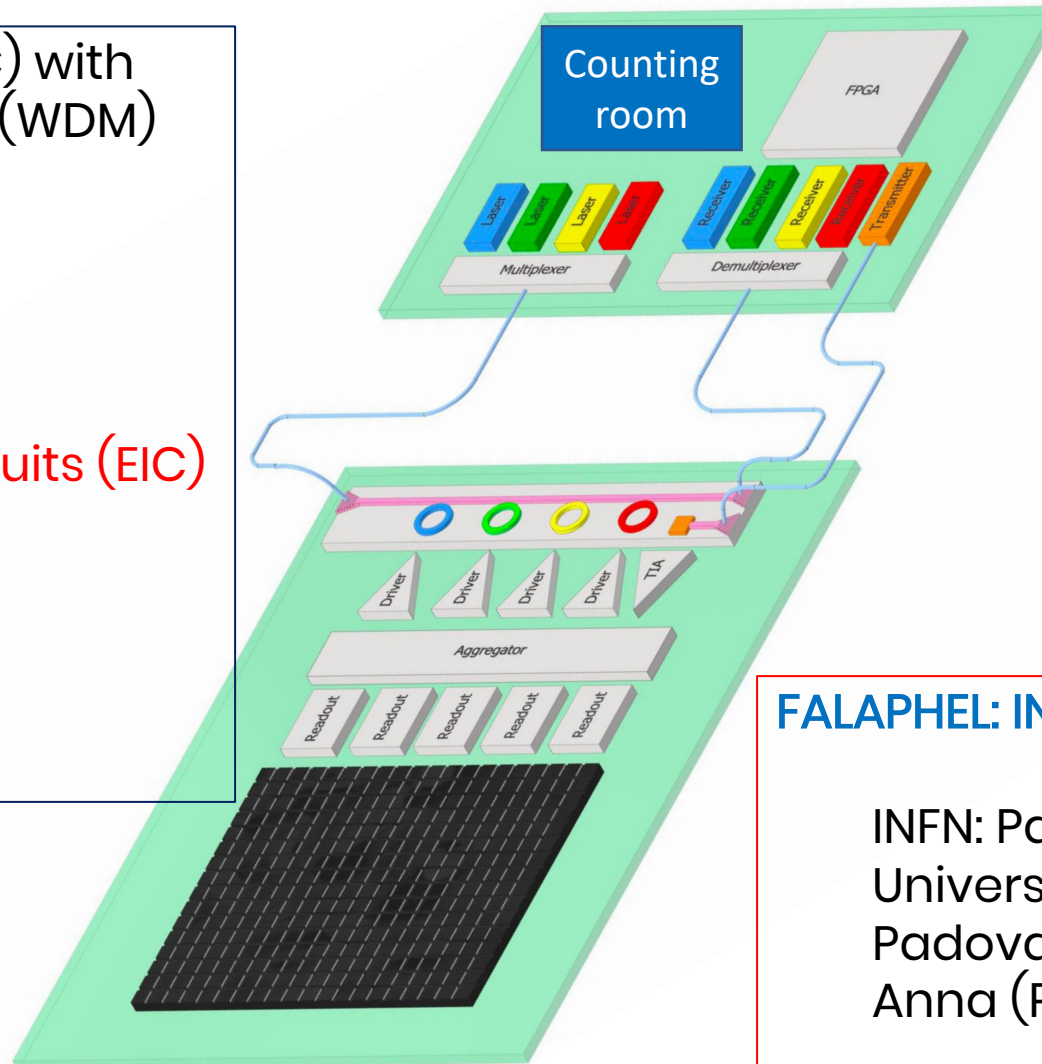
Photonics Integrated Circuits (PIC) with wavelength division multiplexing (WDM)

**Total 100 G = 4x 25G lanes**

Radiation hard

**Needs Electronics Integrated Circuits (EIC)**

- Front-End
- Serialisers
- Drivers
- PLL



**FALAPHEL: INFN Call (2021-2023)**

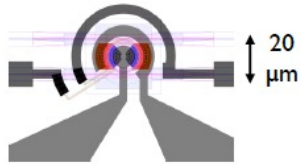
INFN: Padova, Pavia, Pisa  
Universities: Bergamo, Milan,  
Padova, Pisa, Scuola Superiore S.  
Anna (Pisa)

P.I. Fabrizio Palla

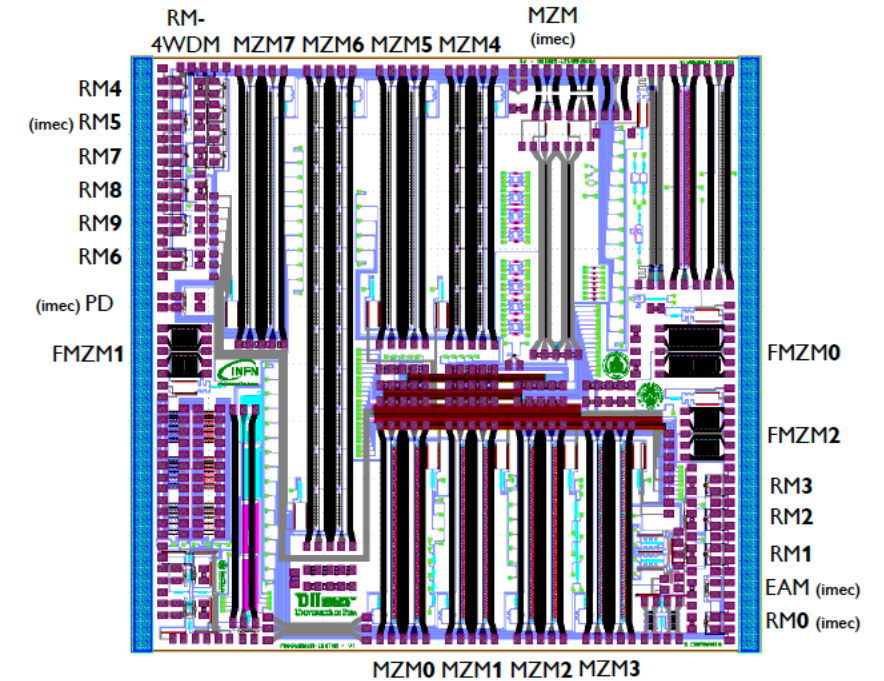
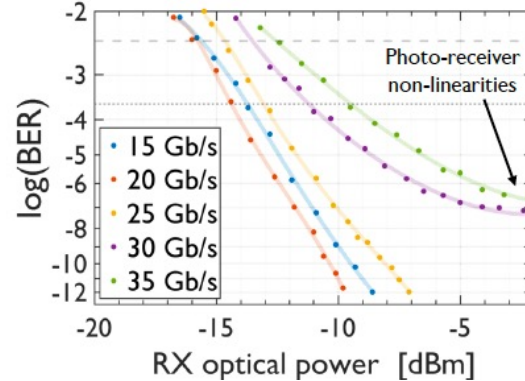
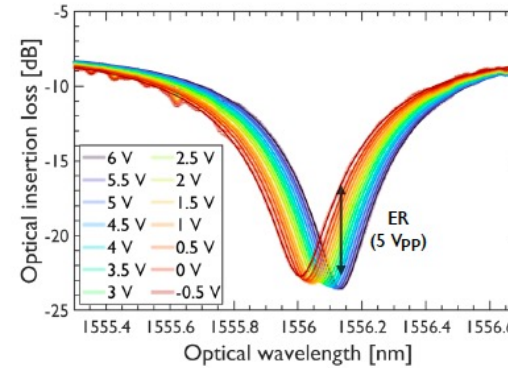
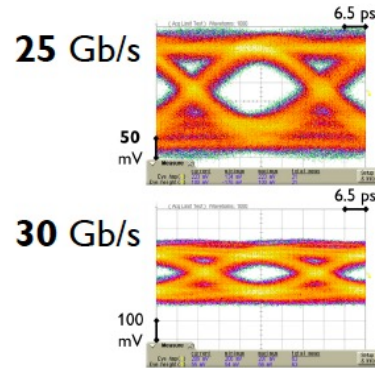
# PIC Technology: iSipp50G by IMEC

## Ring Modulator – RM7

- Ring modulators (**RM**s): light intensity modulation is achieved via resonance shifts produced with a PN phase shifter.
- Testing conditions:  $\lambda = 1556.16 \text{ nm}$ ,  $V_{\text{bias}} = 1.7 \text{ V}$ ,  $V_{\text{pp}} \sim 5 \text{ V}$ ,  $T = 21.3 \text{ }^\circ\text{C}$ ,  $P_{\text{tIs}} = 13 \text{ dBm}$ ,  $\text{OSNR}_{1\text{nm}} = 28.5 \text{ dB}$



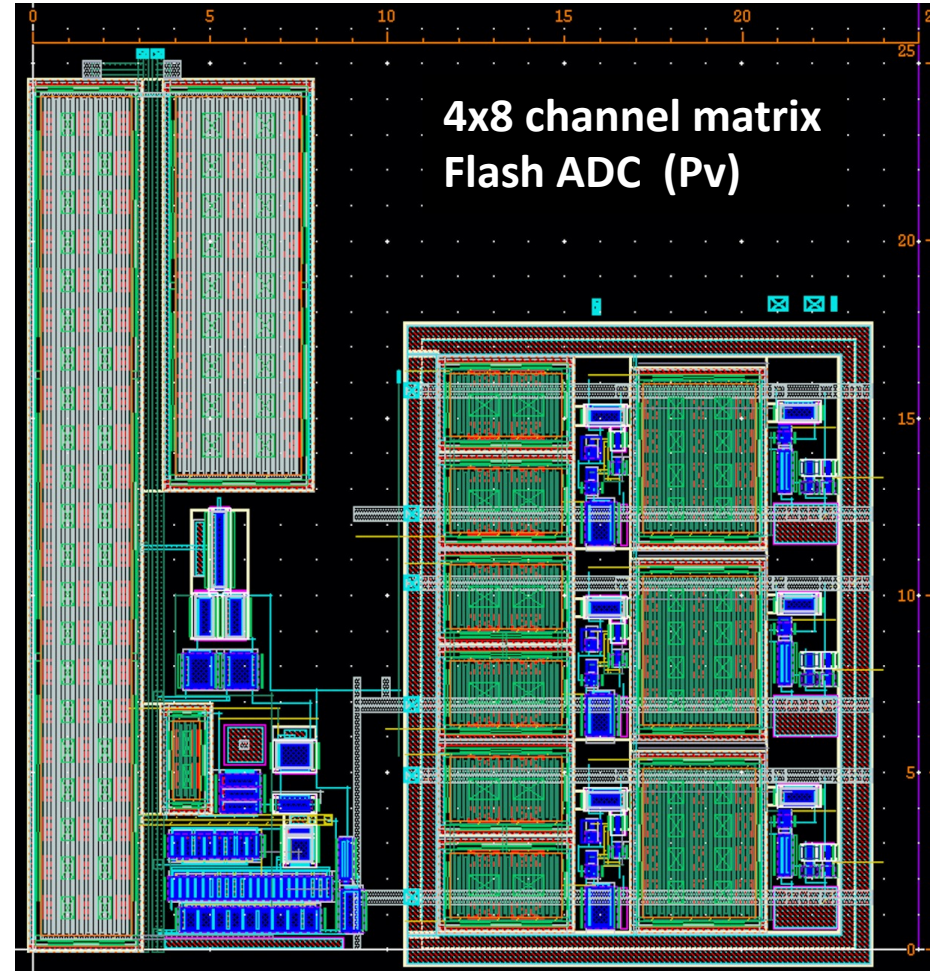
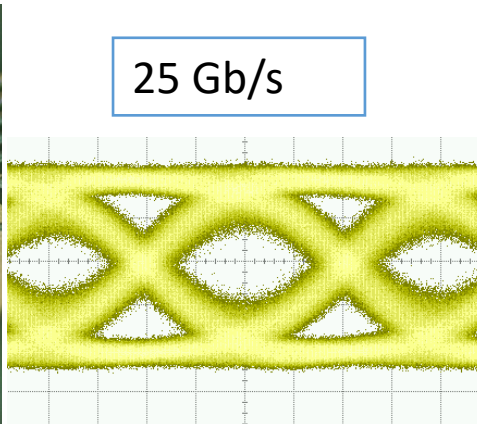
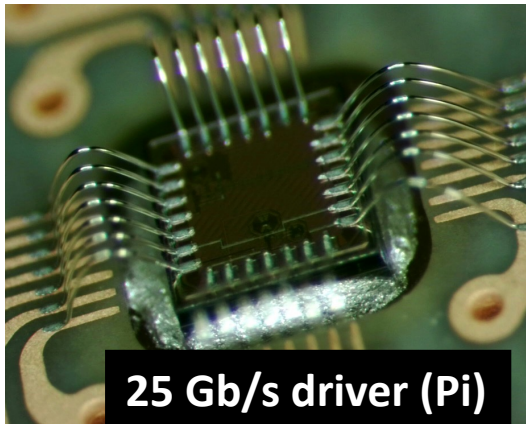
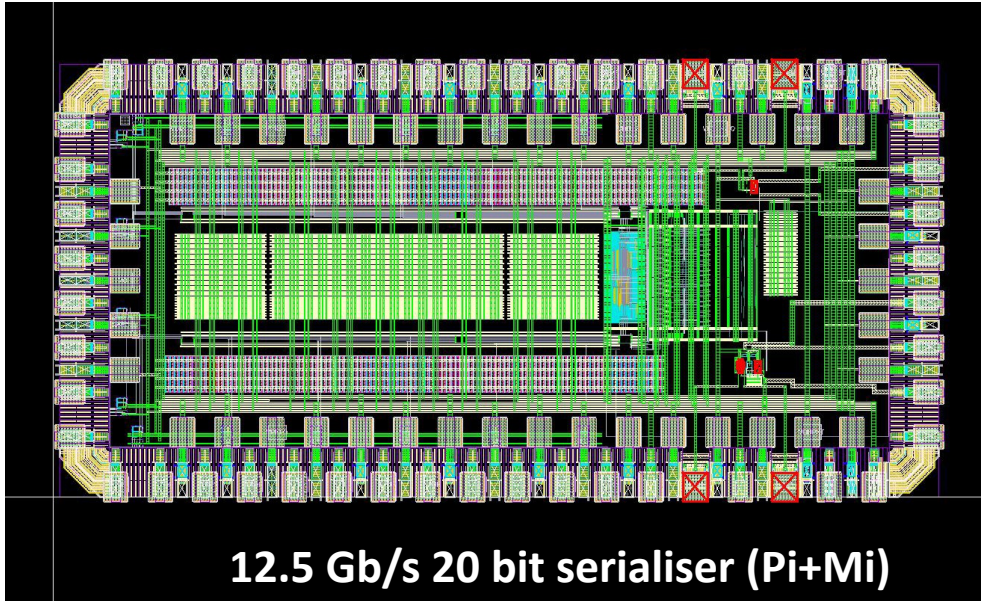
<b>FWHM</b>	~ 790 pm
<b>Quality factor</b>	~ 2000
<b>Modulation depth</b>	~ 15 dB
<b>Modulation efficiency</b>	~ 25 pm/V



5 mm x 5 mm chip



# Electronics Integrated Circuits (28 nm TSMC)



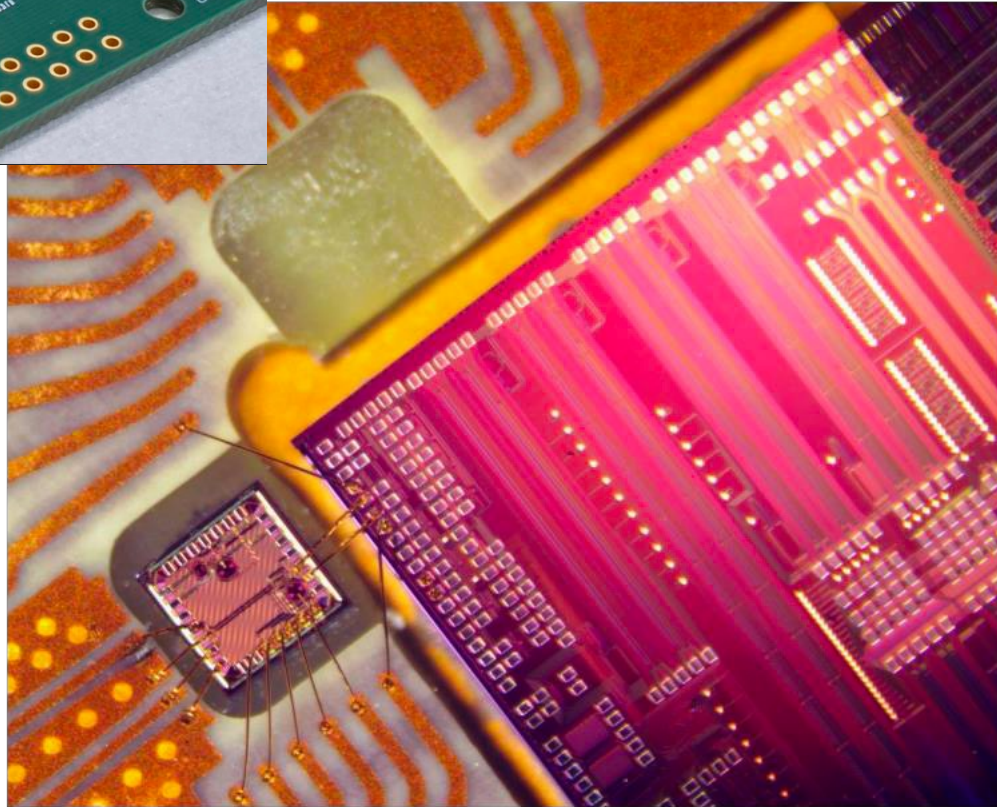
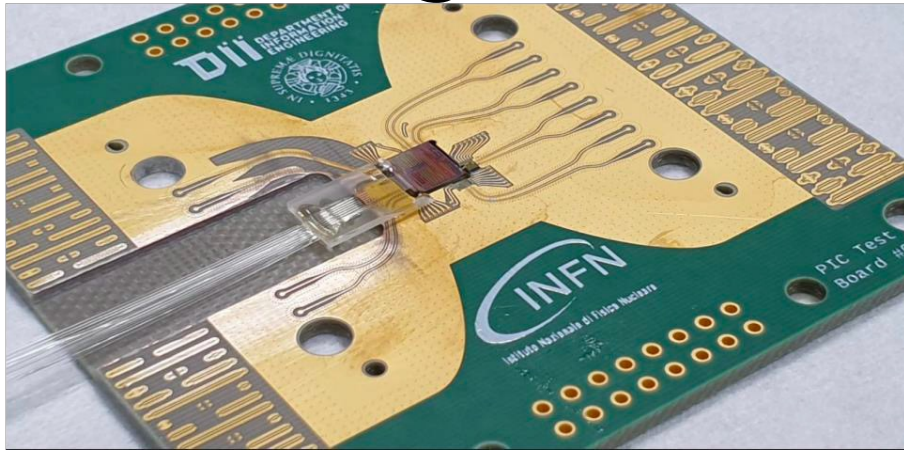
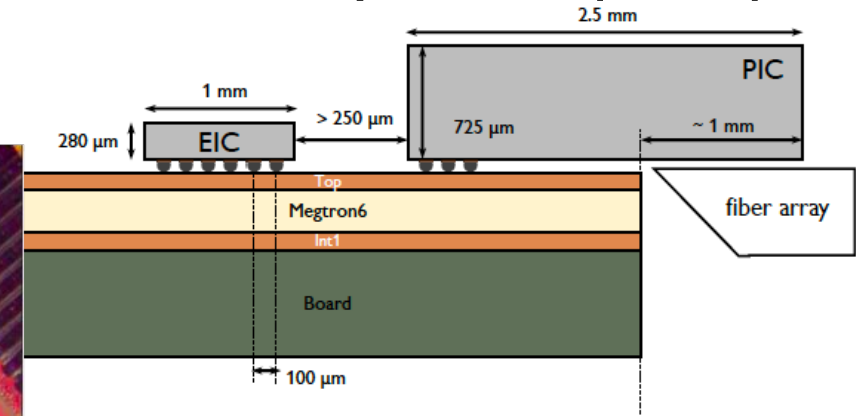


# Integration PIC + EIC



Istituto Nazionale di Fisica Nucleare

- Future: study PCB flip chip



- Wire bond integration at Camgraphic (Pisa)